

## Electronic Patent Application Fee Transmittal

<b>Application Number:</b>	10530026			
<b>Filing Date:</b>	04-Apr-2005			
<b>Title of Invention:</b>	METHOD AND APPARATUS FOR PRODUCING POLYCRYSTALLINE SILICON FILM AND METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE AND THIN-FILM TRANSISTOR			
<b>First Named Inventor/Applicant Name:</b>	Mitsuo Inoue			
<b>Filer:</b>	Jeffrey A. Wyand/Malika Ash Shakur			
<b>Attorney Docket Number:</b>	403363			
Filed as Large Entity				
<b>U.S. National Stage under 35 USC 371 Filing Fees</b>				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
<b>Basic Filing:</b>				
<b>Pages:</b>				
<b>Claims:</b>				
<b>Miscellaneous-Filing:</b>				
<b>Petition:</b>				
<b>Patent-Appeals-and-Interference:</b>				
<b>Post-Allowance-and-Post-Issuance:</b>				
Utility Appt Issue fee	1501	1	1400	1400
Publ. Fee- early, voluntary, or normal	1504	1	300	300

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Extension-of-Time:				
Miscellaneous:				
Printed copy of patent - no color	8001	6	3	18
Total in USD (\$)				1718